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Application Number	10/659,691
Filing Date	September 10, 2003
First Named Inventor	Tseung, Alfred
Group Art Unit	2832
Examiner Name	Easthom, Karl

Sheet 1 of 1

Attorney Docket No: 1260.006US2

US PATENT DOCUMENTS

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date if Appropriate
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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

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Complete if Known	
Application Number	Unknown 12/659671
Filing Date	Even Date Herewith
First Named Inventor	Tseung, Alfred
Group Art Unit	Unknown
Examiner Name	Easthorn, Karl

Sheet 1 of 1 Attorney Docket No: 1260.006US2

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12		CHIU, C., et al., "The influence of microstructure and eposition methods on CO gas sensing properties of La0.8Sr0.2Co1-xNixO3-? perovskite films", <u>Sensors and Actuators B 54</u> , (1999),236-242	
12		SATAKE, KAZUKO, "CO GAS SENSING ELEMENT (Abstract)", <u>Patent Abstracts of Japan - JP 08 2200 45 A (Tokuyama Corp.)</u> , Vol. 1996, No. 12, 26 December 1996,	

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